

Beam Splitter - 1550 nm

Generated 7/9/2026, 11:45:32 AM · Provider: AI Copilot · qxphoton-engine/0.2.0 [gdsfactory+analytic-v2]

Design Summary

This 50:50 beam splitter is designed on a silicon photonics (SOI) platform with the objective of minimizing insertion loss at a 1550 nm operating wavelength. The analytic estimates indicate a transmission efficiency of 97.2%, equivalent to an insertion loss of 0.123 dB (the same transmission expressed two ways), across a 90.0 nm bandwidth. The directional-coupler geometry uses a 0.5 μm waveguide width, a 0.23 μm gap, an 18.4 μm coupling length, and a 10 μm bend radius, yielding a compact footprint of 25.5 \times 1.75 μm . With a fabrication score of 94.2/100, the design appears robust and well-suited to standard SOI processes. These figures are analytic estimates rather than the result of a full physical simulation.

Specification

Component	Beam Splitter
Wavelength	1550 nm
Objective	Minimize Insertion Loss
Platform	Silicon Photonics (SOI)
Split Ratio	50:50
Constraints	minimal insertion loss
Parameters	gap_um=0.23, wg_width_um=0.5, bend_radius_um=10, coupling_length_um=18.4

Estimated Performance

Efficiency	97.2 %
Insertion Loss	0.12 dB
Bandwidth	90 nm
Fabrication Score	94 / 100

Layout

Footprint	25.5 \times 1.75 μm
Layers	2